



# 14/Not. of app  
3/26/03  
C.P.

Atty Docket No.: 0630.0021C

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the PATENT application of:

Berry et al

Serial No.: 09/505,695

Filed: February 17, 2000

For: Method of Photoresist Ash Residue Removal

Examiner: Le, Thao

Group Art Unit: 2814

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NOTICE OF APPEAL

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Examiner, dated November 18, 2002, finally rejecting claims of the application.

A check in the amount of \$320.00 is enclosed for payment of the Notice of Appeal Fee under 37 C.F.R. § 1.17(b). Also enclosed is a Petition for Extension of Time under 37 C.F.R. § 1.136(a).

Please charge any additional fees or credit any overpayment to Deposit Account No. 05-0460.

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320.00 OP

Respectfully submitted,

Martin Abramson

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Hand Delivered: March 17, 2003